ATTORNEY DOCKET NO. 43890-485 PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

n re Application of:)
Hiroshi HAJI et al.) Attn: APPLICATIONS BRANCH
Serial No.: To Be Assigned)
Filed: February 13, 2001)
For: METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE)))

PRELIMINARY AMENDMENT

Hon. Assistant Commissioner for Patents Washington, DC 20231

Sir:

Prior to examination of the above-identified application, please amend the application as follows:

IN THE SPECIFICATION:

Please amend the specification as follows:

Page 1, line 6: after "device," insert -- and --.

Page 2, line 9: after "right" insert --proper--.

Page 4, line 19: after "may be" insert --uniformly-- and delete "uniformly".

Page 5, line 2: change "the" (first occurrence) to --these--;

line 11: after "wafer 1" insert --to-be--;